



BPM electronics

Douglas BETT, BE-BI-BP



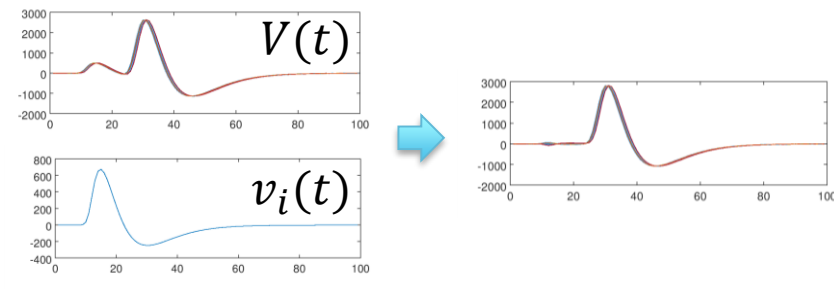
HL-LHC WP13 BI Meeting 2020 #6

Study items from last session

- Bunch length variations to be considered
 - Variable bunch length implemented in the simulation. Range clearly stated in specification: 0.7 – 1.2 ns (FWHM)
- Can VNA style corrections be used?
 - Unlikely. A method of recovering the individual beam signals from the set of waveforms was implemented but performed less well than the other methods.
- Use on-board DAC to generate similar signals
 - Pending.
- RF full detuning effects to be considered
 - Pending.
- Can an algorithm be found that does not need beam calibration
 - The VNA method, but it has already been ruled out.

Comparison of compensation methods I

- Waveform compensation
 - Sample-by-sample adjustment of the amplitude of the waveform samples
 - Requires template waveforms (and hence making assumptions about the bunch and signal processing)
- Power compensation
 - Adjustment of the calculated power of the waveforms
 - Requires power compensation parameters (calculated from template waveforms)
- VNA-style compensation
 - Beam-independent, but requires knowledge of the stripline S-parameters



$$V(t) = \rho_0 v_c(t) + \rho_9 v_i(t)$$

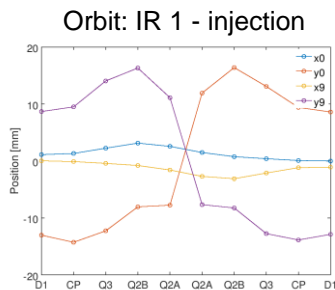
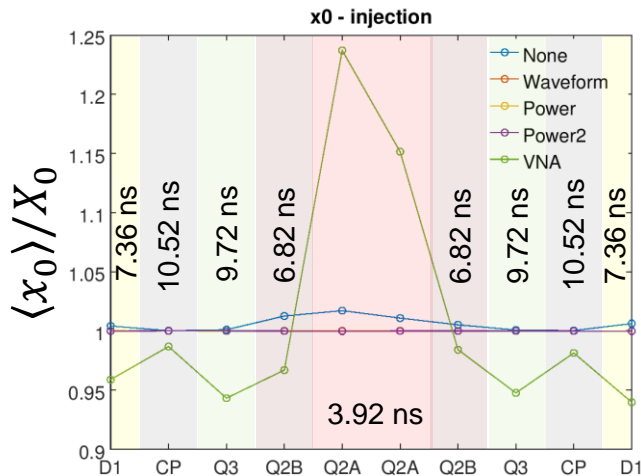
$$\sum V(t)^2 = \rho_0^2 \sum v_c(t)^2 + 2\rho_0\rho_9 \sum v_c(t) \cdot v_i(t) + \rho_9^2 \sum v_i(t)^2$$

Can be solved for ρ_0 if ρ_9 is known

$$\rho_{R0} I_0(\omega) = \frac{I_1(\omega) \cdot S_{59}(\omega) - I_5(\omega) \cdot S_{19}(\omega)}{S_{10}(\omega) \cdot S_{59}(\omega) - S_{19}(\omega) \cdot S_{50}(\omega)}$$

Current cancels out when taking Δ/Σ

Compensation of comparison methods II

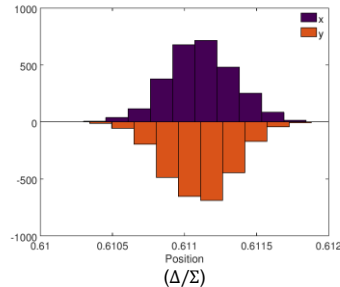
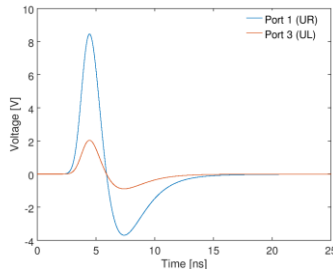
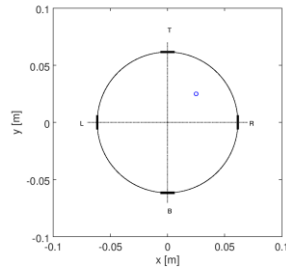
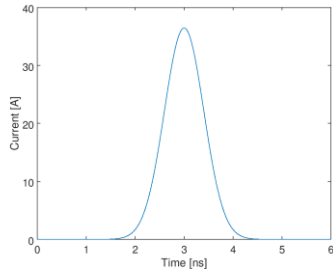


- Consider two beams with equal intensity ($=3e11$) and bunch lengths of 75 mm*
- Using the specified injection orbits for each BPM (IR 1), calculate the position of the first beam using several different methods to account for the presence of the other beam
- X_0 is the calculated position of the beam taking into account only the geometry
- x_0 is the position of the beam calculated from the digitized (and compensated) ensemble of waveforms
- The VNA method performs very poorly and was eliminated from consideration
- Waveform and power compensation perform similarly well, but waveform compensation is much more computationally intensive

*shorter than the minimum quoted in the specification

Simulation properties

- Consider a single beam travelling through the Q1 BPM
 - 25 mm off axis in both horizontal and vertical directions (max operational range)
 - variation in waveforms solely due to asynchronous phase of sampling clock and random noise applied during digitization

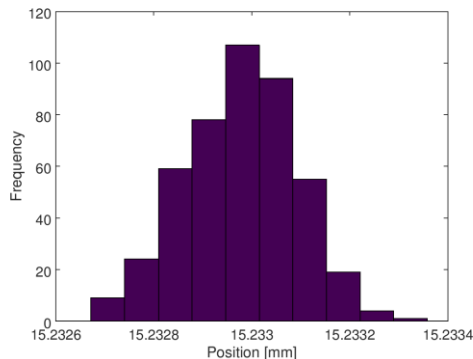


Simulation properties

Beam 0 intensity (i_0)	2.3×10^{11} (max)
Beam 0 bunch length (σ_0)	0.95 ns (mid-range)
Cable	LCF12-50JFN [100 m]
Filter	Absorptive [273 MHz]
Sampling frequency	3994.9 MHz (1 in 255)
ADC	12-bit, ± 0.5 V, use 2/3
Attenuator step size	2 dB
Random noise	1.5611 counts

Specification

- Target: averaged Closed Orbit (CO) measurement stable to within $2\ \mu\text{m}$ on a 10 hour timeframe
- Frequency of CO measurements = 25 Hz i.e. once every 40 ms
 - Train makes 450 revolutions of the LHC in this time
 - Train consists of 2,760 bunches
 - So each CO orbit measurement gives the average of ~ 1.25 million individual bunch position measurements



- Histogram plot of the **mean** position for 450 bunch trains (of 2760 bunches)
- Error on mean = 5.3 nm
- NB: a linear calibration constant equal to half the BPM radius has been used for these results. In reality a 2D polynomial will be required to correct the non-linearity. The true errors will therefore be higher.

0.8 μm

Factors that could affect position

Bunch length [ns]	Closed orbit position
0.70	15.232944 mm \pm 5.4 nm
0.95	15.232977 mm \pm 5.3 nm
1.20	15.232938 mm \pm 4.8 nm

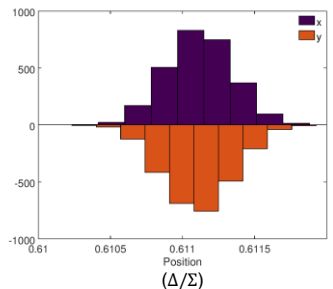
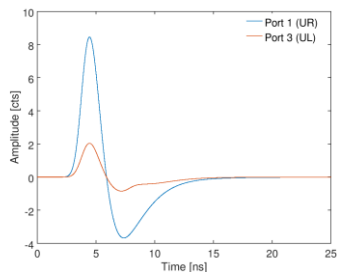
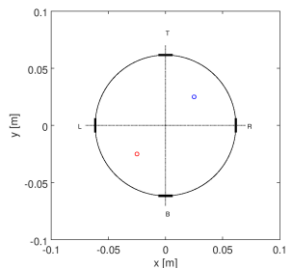
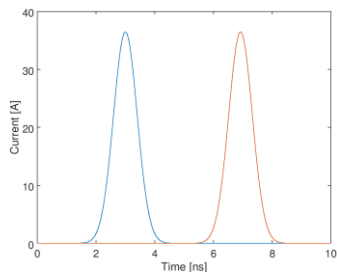
Closed orbit measurement differs by up to 0.04 μ m as bunch length varied

Bunch charge	Closed orbit position
5e9	15.232896 mm \pm 6.8 nm
5e10	15.232960 mm \pm 5.5 nm
2.3e11	15.232977 mm \pm 5.3 nm

Closed orbit measurement differs by up to 0.08 μ m as bunch charge varied

Add second beam

- Positioned opposite end of BPM to the first beam (max anticipated offset?)
 - Equal intensity (max)
 - Same bunch length (mid-range)



Simulation properties

Beam 0 intensity (i_0)	2.3×10^{11} (max)
Beam 9 intensity (i_9)	2.3×10^{11} (max)
Beam 0 bunch length (σ_0)	0.95 ns (mid-range)
Beam 9 bunch length (σ_9)	0.95 ns (mid-range)
Bunch crossing timing	3.92 ns (Q1)
Cable	LCF12-50JFN [100 m]
Filter	Absorptive [273 MHz]
Sampling frequency	3994.9 MHz (1 in 255)
ADC	12-bit, ± 0.5 V, use 2/3
Attenuator step size	2 dB
Random noise	1.5611 counts

Two beam results

	Beam 0	Beam 9
Target	15.232942 mm	-15.232942 mm
Uncompensated	15.416821 mm	-15.414105 mm
Compensated	15.231842 mm	-15.233208 mm

Adding the second beam in the specified location shifts the apparent position by:

184 μm (beam 0)

-181 μm (beam 9) (without compensation)

Using the method of power compensation (assuming 0.95 ns width bunches), the shift is:

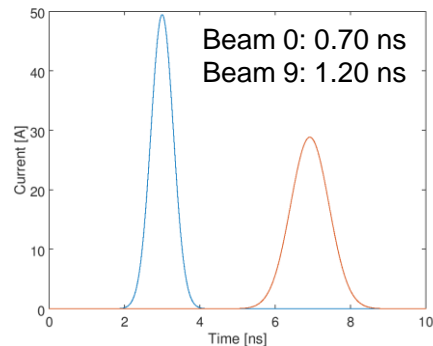
-1.1 μm (beam 0)

-0.3 μm (beam 9)

When non-linearity taken into account, beam 0 shift likely to already be close to 2 μm level

Changed bunch length

	Beam 0	Beam 9
Target	15.232942 mm	-15.232942 mm
Uncompensated	15.406058 mm	-15.426068 mm
Compensated	15.232942 mm	-15.233361 mm



Changing the bunch lengths of both beams shifts the apparent position by:

173 μm (beam 0)

-193 μm (beam 9) (without compensation)

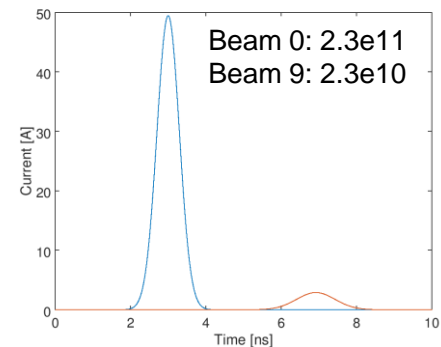
Using the method of power compensation (assuming 0.95 ns width bunches), the shift is:

0.1 μm (beam 0)

-0.4 μm (beam 9)

Changed bunch charge

	Beam 0	Beam 9
Target	15.232942 mm	-15.232942 mm
Uncompensated	15.253587 mm	-12.503724 mm
Compensated	15.232876 mm	-15.138006 mm



Changing the bunch lengths of both beams shifts the apparent position by:

20.6 μm (beam 0)

2.73 mm (beam 9) (without compensation)

Using the method of power compensation (assuming 0.95 ns width bunches), the shift is:

-0.07 μm (beam 0)

94.9 μm (beam 9)

Conclusion

- Power compensation now the baseline method for compensating for the other beam
- 2 μm tolerance over the entire operational range likely to be extremely challenging once real-world effects taken into account